

SURFCOM NEX (DX2/SD2) Series

SURFCOM NEX

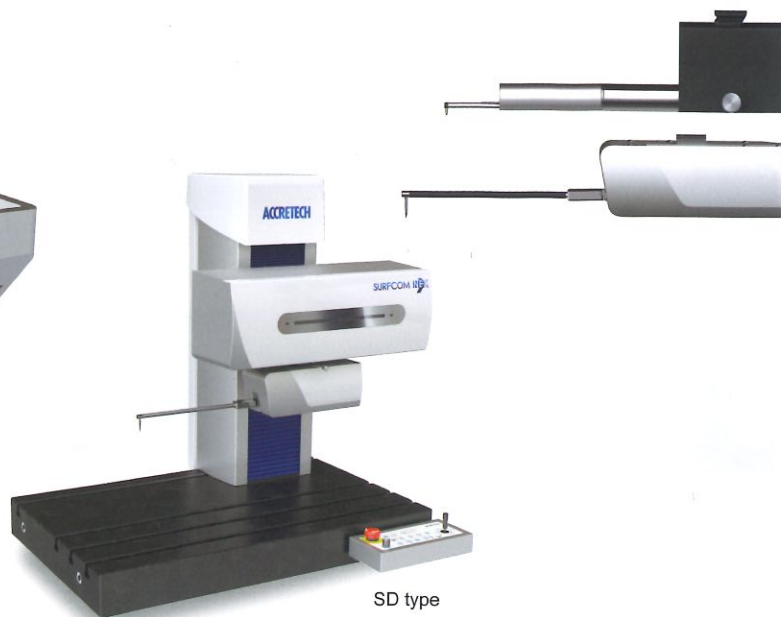
041 DX2/SD2

Dedicated catalog is available.

A complex measuring instrument that
enables surface roughness measurement
and high accuracy contour measurement



DX type



SD type

NEX 041 DX2/SD2 is a complex model capable of surface roughness measurement and high accuracy contour measurement. (Necessary to replace detector)
*Tracing driver tilting device is optional. Please refer to page 22 to 23 for surface roughness measurement and page 18 to 21 for contour profile measurement.

Measurement unit

Item				Model	SURFCOM NEX (DX2/SD2)							
					12	13	14	15	22	23	24	25
Tracing driver	X-axis (L: measuring length mm)	Sensing method			Linear scale							
		Straightness accuracy (When standard styl ⁱ are used)	with High-accuracy contour detector	0.8 μm/100 /mm				2.0 μm/200 /mm				
			with Roughness pickup	(0.05+1.0L/1000) μm (L: Measuring length mm)								
		X-axis indication accuracy: horizontal* ¹			±(0.8+1.0L/100) μm (L: Measuring length mm) *Contour measurement with 100 mm driver							
		Resolution			±(0.8+3.0L/200) μm (L: Measuring length mm) *Contour measurement with 200 mm driver							
		Speed			0.016 μm							
		Travel speed			0.03 to 100 mm/s							
		Measuring speed			0.03 to 30 mm/s							
Measuring stand	Column	Tilt angle			±15 ° (Optional tilting device)							
		Speed	Travel speed	CNC	Max. 50 mm/s							
	Base	Material		Joystick	Max. 35 mm/s							
						Gabbro						

Detector

High-accuracy contour detector	Measuring range	Z-axis: vertical		60 mm
	Contour	Sensing method		Laser optical diffraction scale
		Resolution		0.02 μm (Full range)
		Indication accuracy: vertical		±(0.8+2 H /100) (H: Measuring height mm)
	Stylus	for Contour	Model	DM45505 (Standard accessory for *4*)
			Measuring force	2 to 30 mN (Adjustable on measuring/analysis integrated software "ACCTee")
			Tip material	Cemented carbide
Tip shape			Rtip 25 μm/24° cone	
Function		Down/upward measurements / Collision detection safety function / Retract function		
Roughness pickup	Measuring range	Z-axis: vertical		1000 μm
	Roughness	Sensing method		Differential inductance
		Measuring range		6.4 to 1000 μm
		Resolution		0.1 to 20 nm
	Stylus	for Roughness	Model	DM43801 (Standard accessory for NEX™)
			Measuring force	0.75 mN
			Tip material	Diamond
			Tip shape	Rtip 2 μm/60° cone
Function		Down/upward measurements / Upper limit detection safety mechanism		

*1 Excluding when using roughness pickup